

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Harshbarger, et al.

Serial No.: 10/052,878

Confirmation No.: 4040

Filed:

November 2, 2001

For:

Method of Depositing Amorphous

Silicon Based Films Having Controlled Conductivity

MAIL STOP NON-FEE AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

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Group Art Unit: 2814

Examiner:

G. Peralta

RECEIVEL

TECHNULUGY CENTER 2800

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on November 12, 2003, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents. P.O. Box 1450. Alexandria, VA 22313-1450.

///L/63 Date

Signature

RESPONSE TO OFFICE ACTION DATED AUGUST 13, 2003

In response to the Office Action dated August 13, 2003, having a shortened statutory period for response set to expire on November 13, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/ AMAT/0872.C1/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks/Arguments begin on page 5 of this paper.